

<b>Notice of References Cited</b>	Application/Control No. 10/829,309	Applicant(s)/Patent Under Reexamination LEE, CHANG-HUNG	
	Examiner Marie Antoinette Cabucos	Art Unit 2163	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,819,266	10-1998	Agrawal et al.	707/6
*	B	US-6,094,645	07-2000	Aggarwal et al.	706/47
*	C	US-6,189,005	02-2001	Chakrabarti et al.	707/6
*	D	US-6,236,982	05-2001	Mahajan et al.	706/45
*	E	US-6,263,327	07-2001	Aggarwal et al.	706/47
*	F	US-6,278,998	08-2001	Ozden et al.	707/6
*	G	US-6,836,777	12-2004	Holle, Dan	707/101
*	H	US-2001/0037324	11-2001	Agrawal et al.	707/1
*	I	US-2003/0023591	01-2003	Ma et al.	707/6
*	J	US-2003/0078686	04-2003	Ma et al.	700/91
*	K	US-2003/0097367	05-2003	Ma et al.	707/102
*	L	US-2003/0217055	11-2003	Lee et al.	707/6
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.